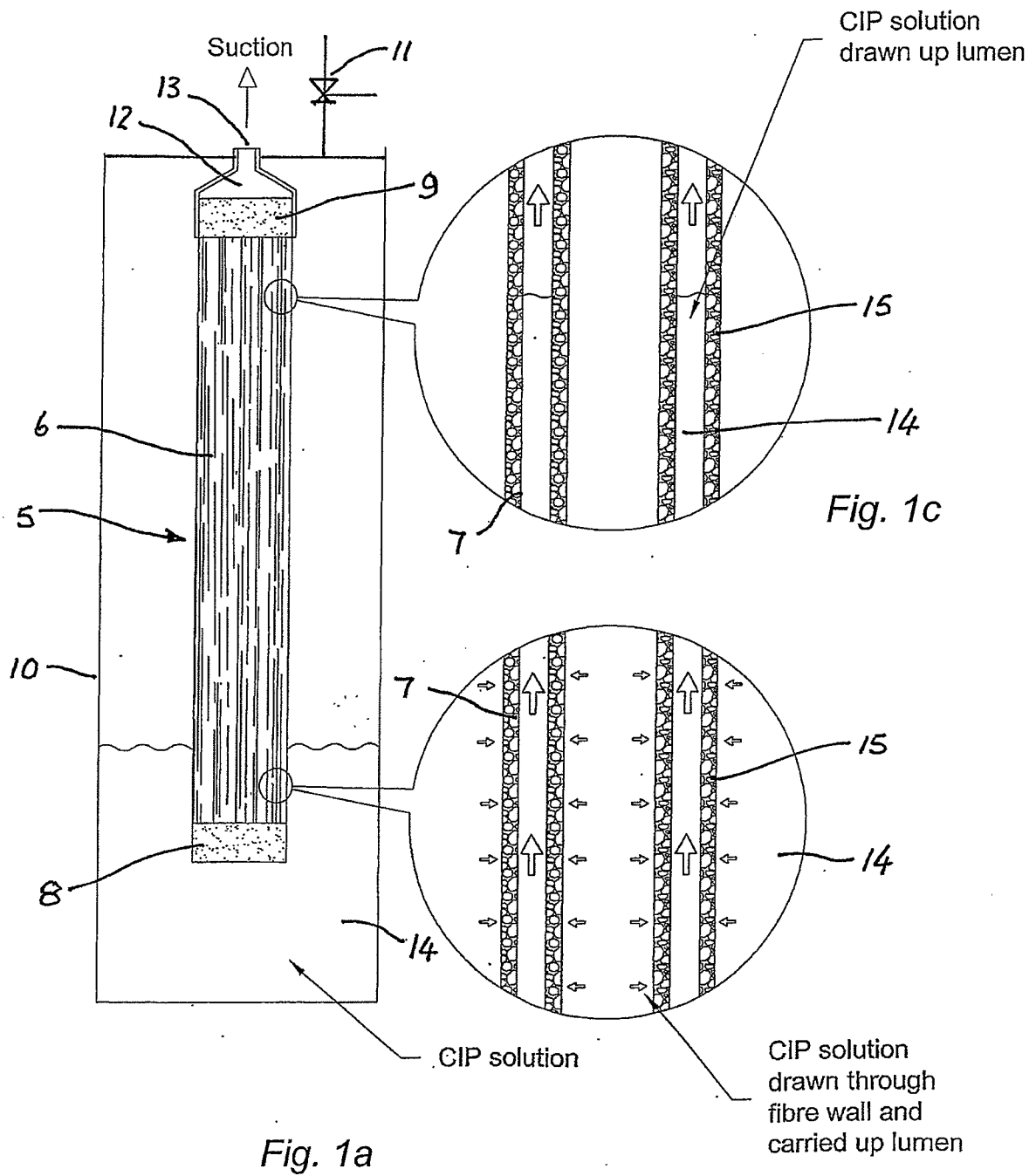
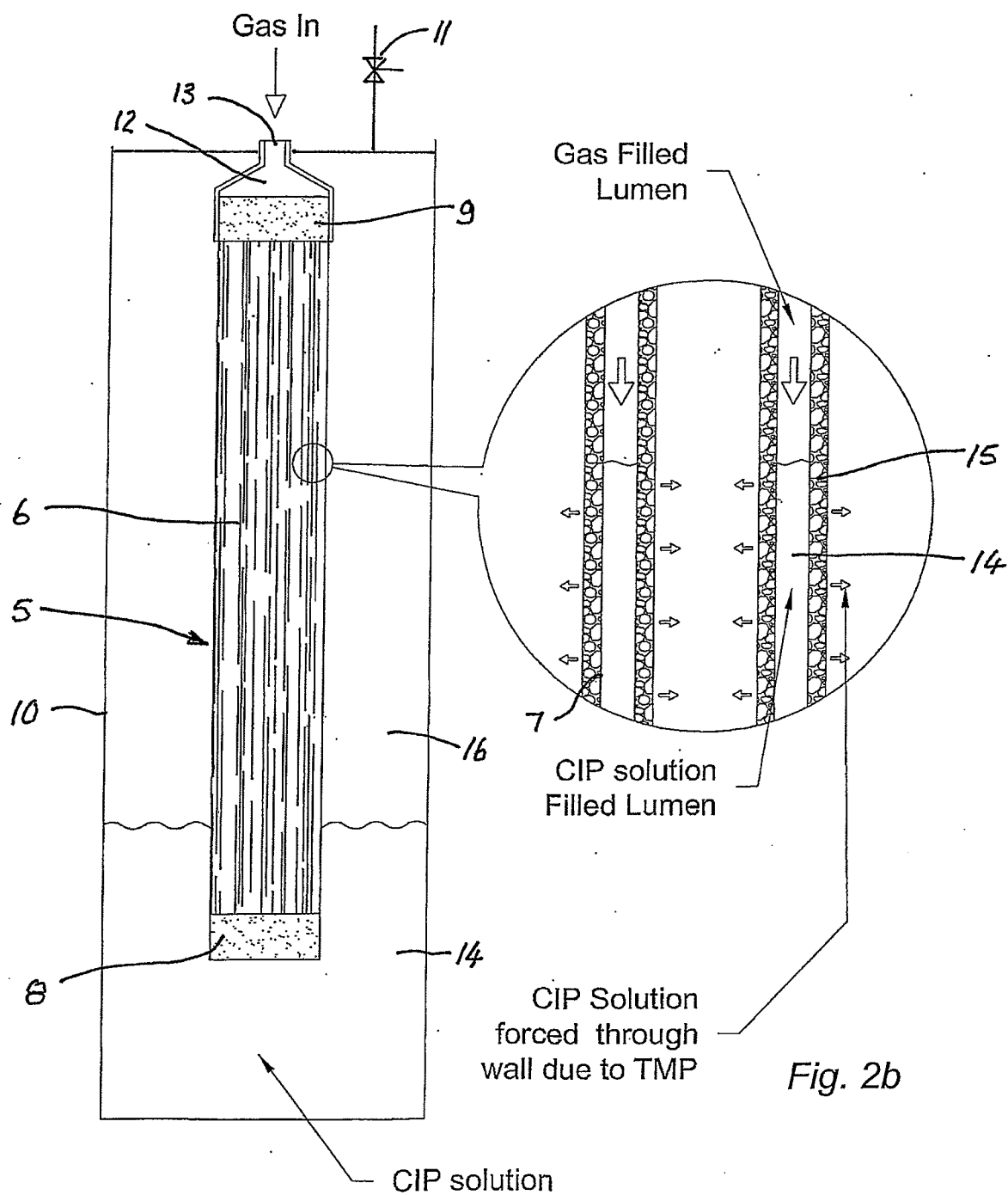






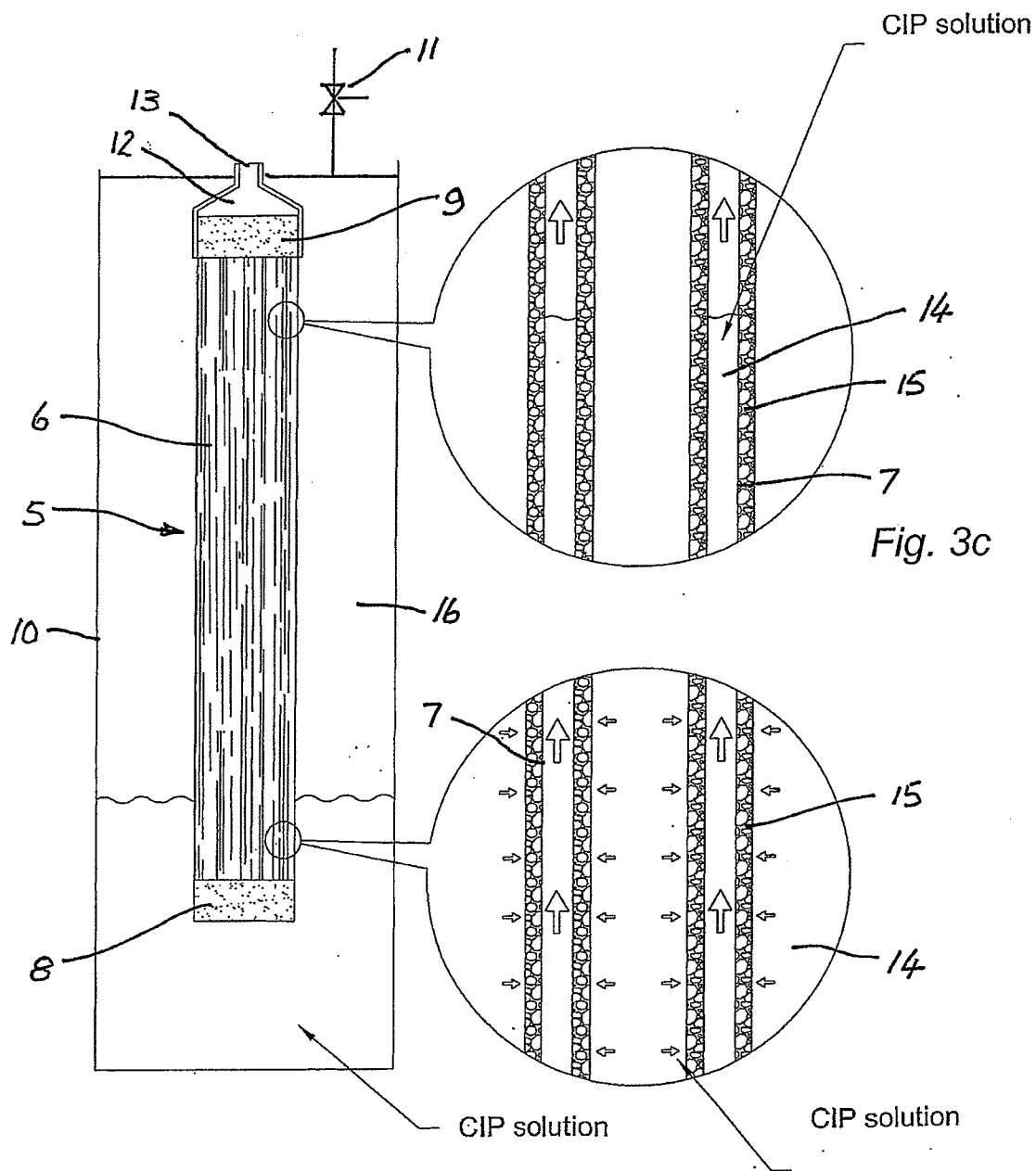
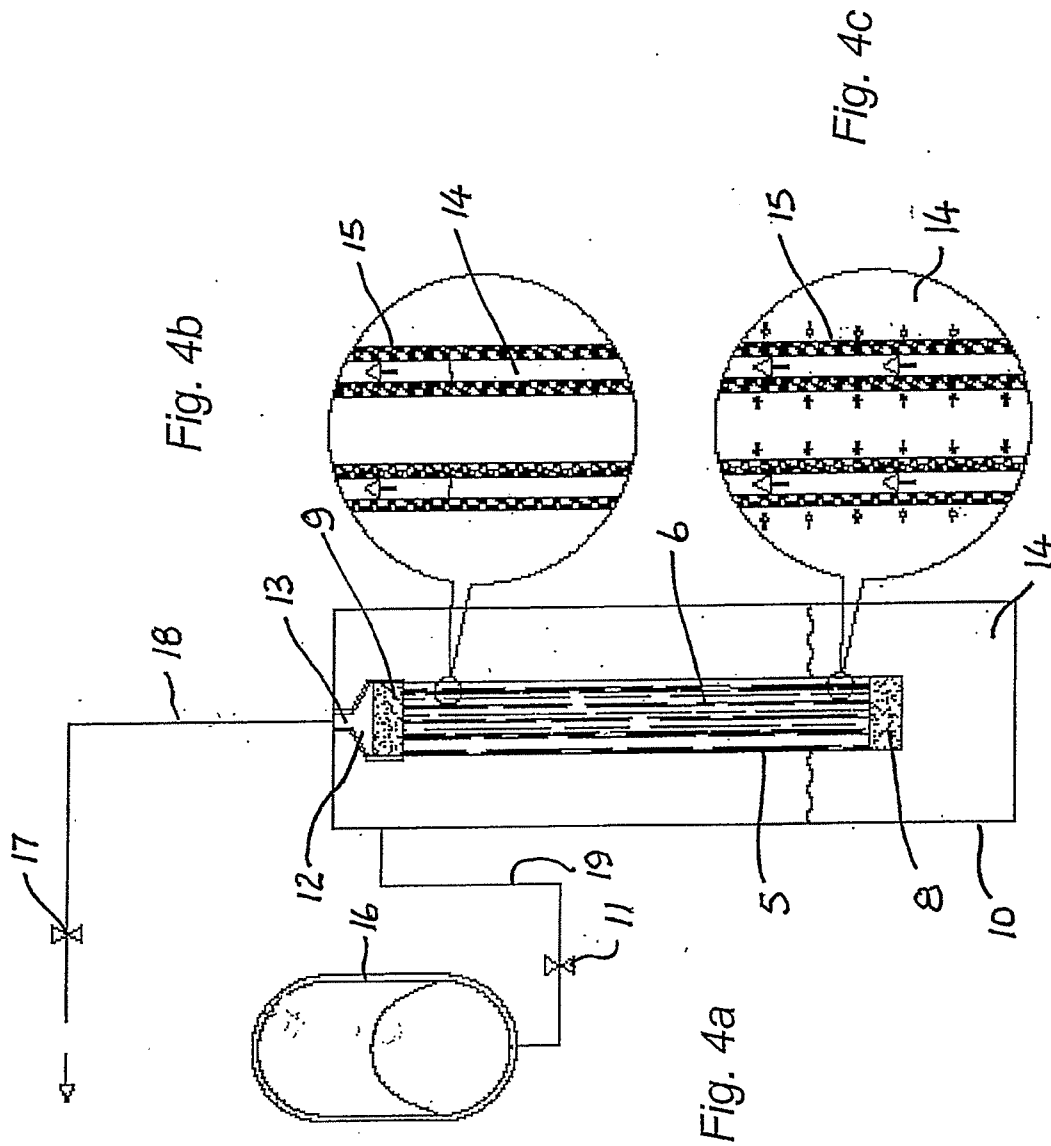
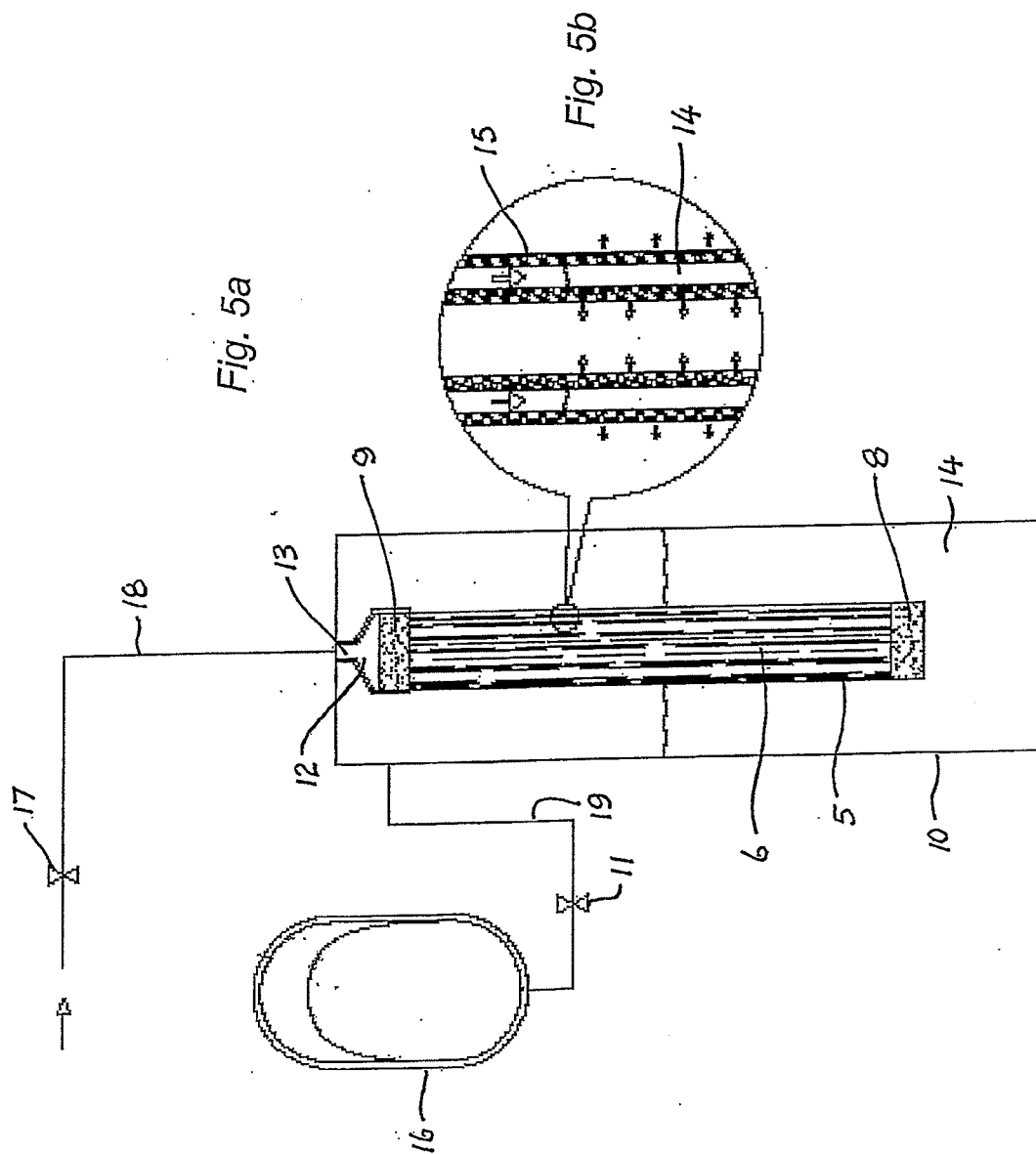
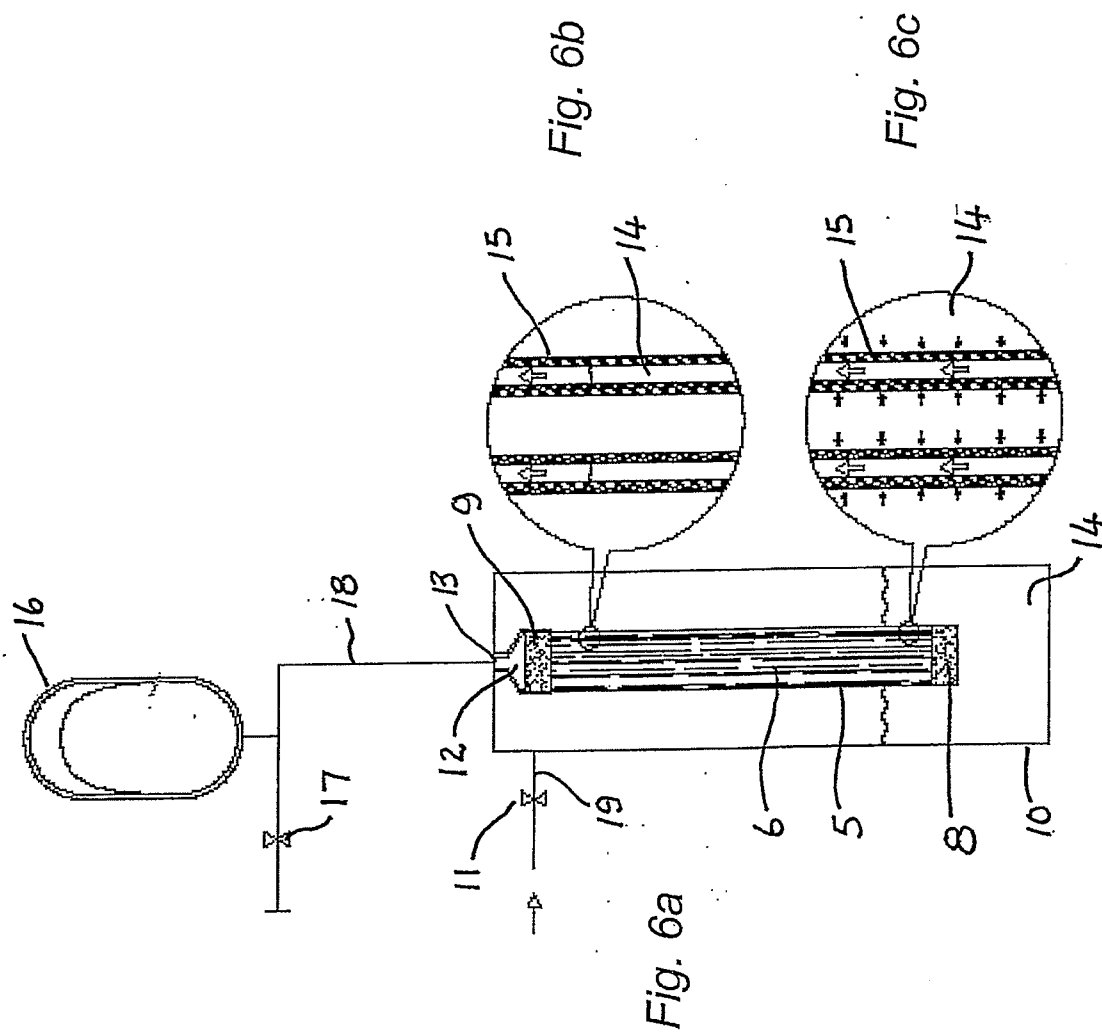


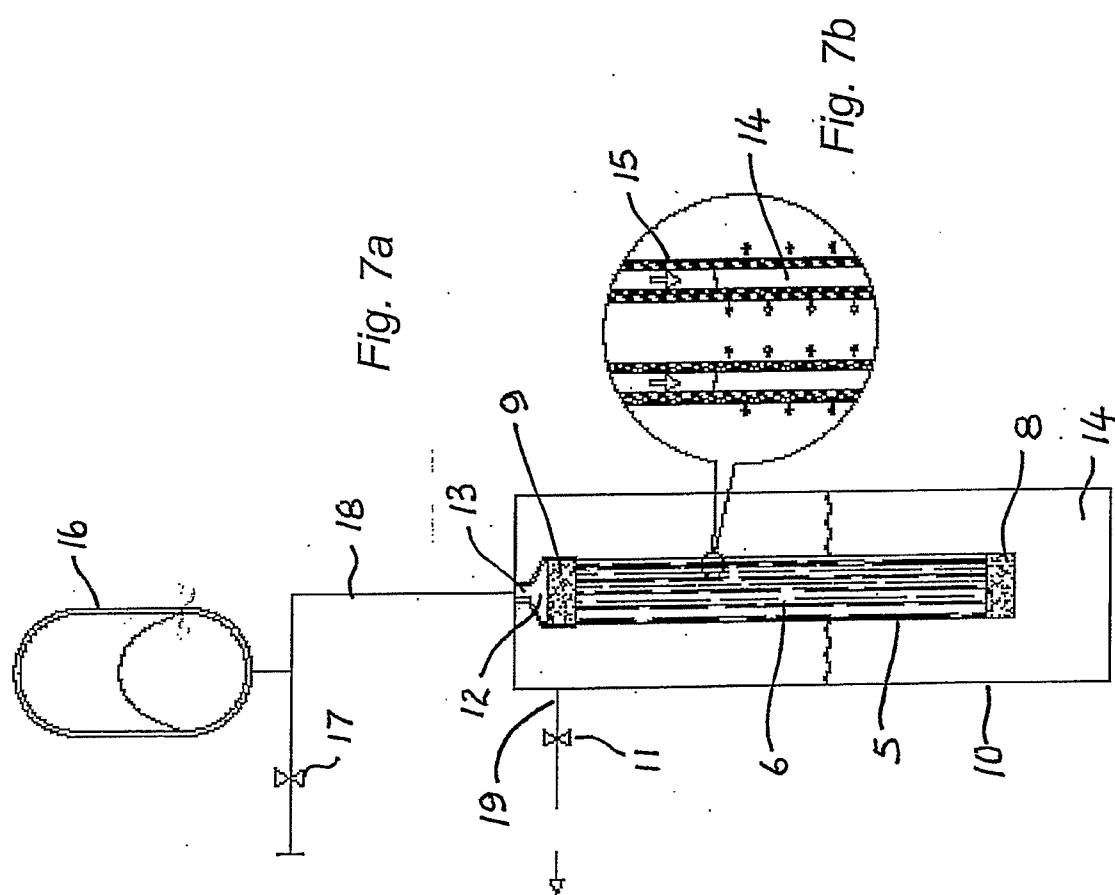
Fig. 3a

Fig. 3b









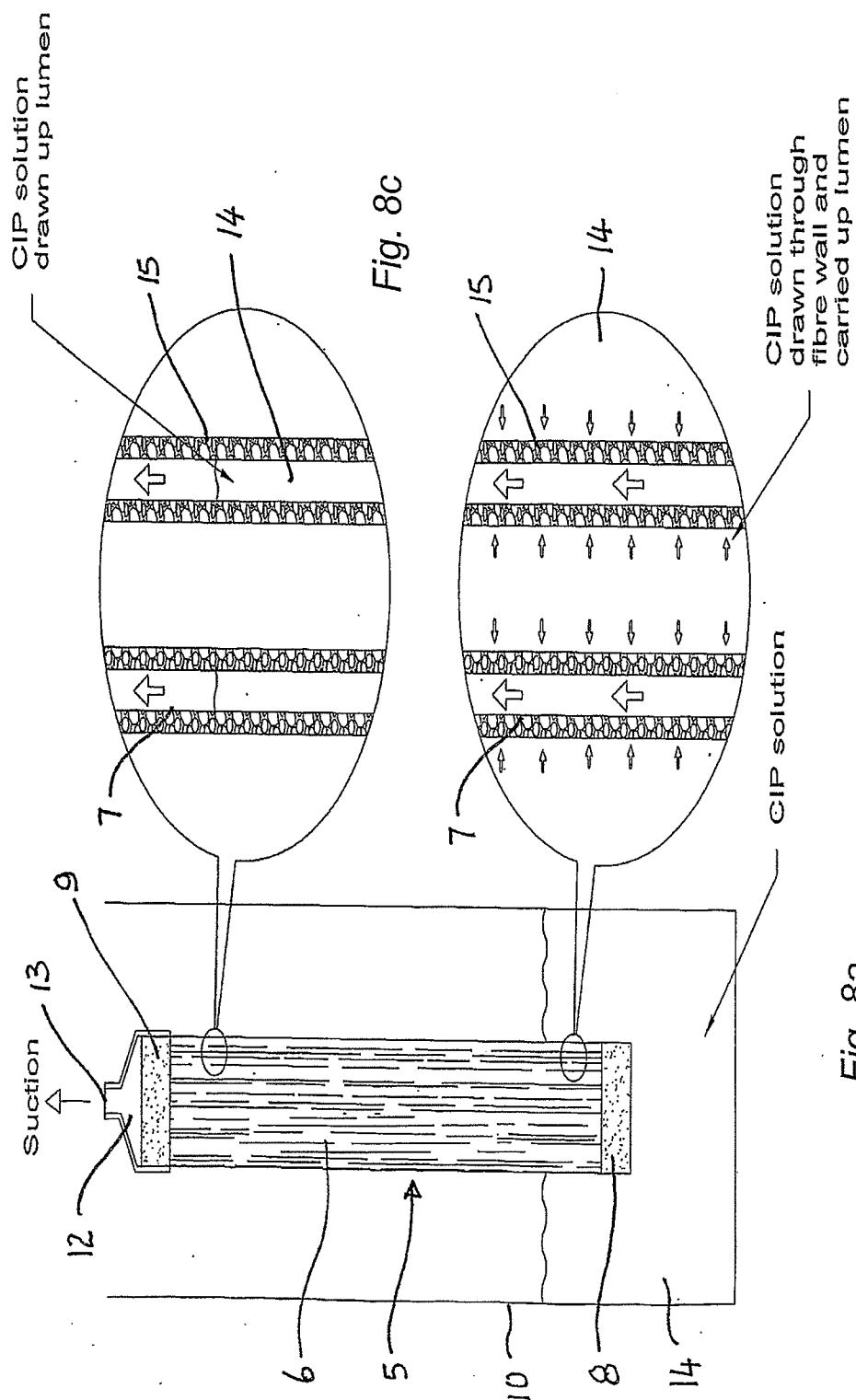
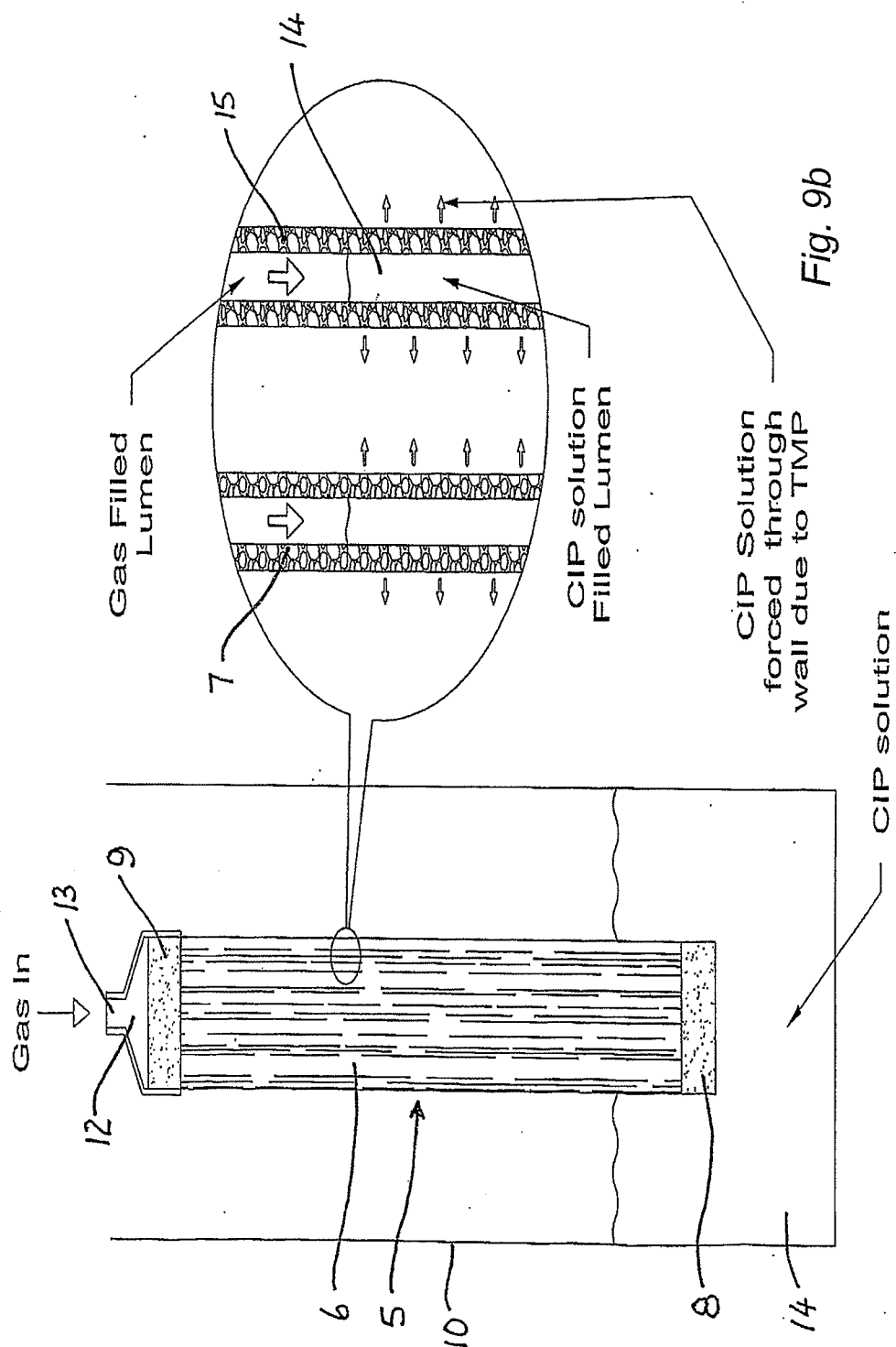


Fig. 8a

Fig. 8b

Fig. 8c



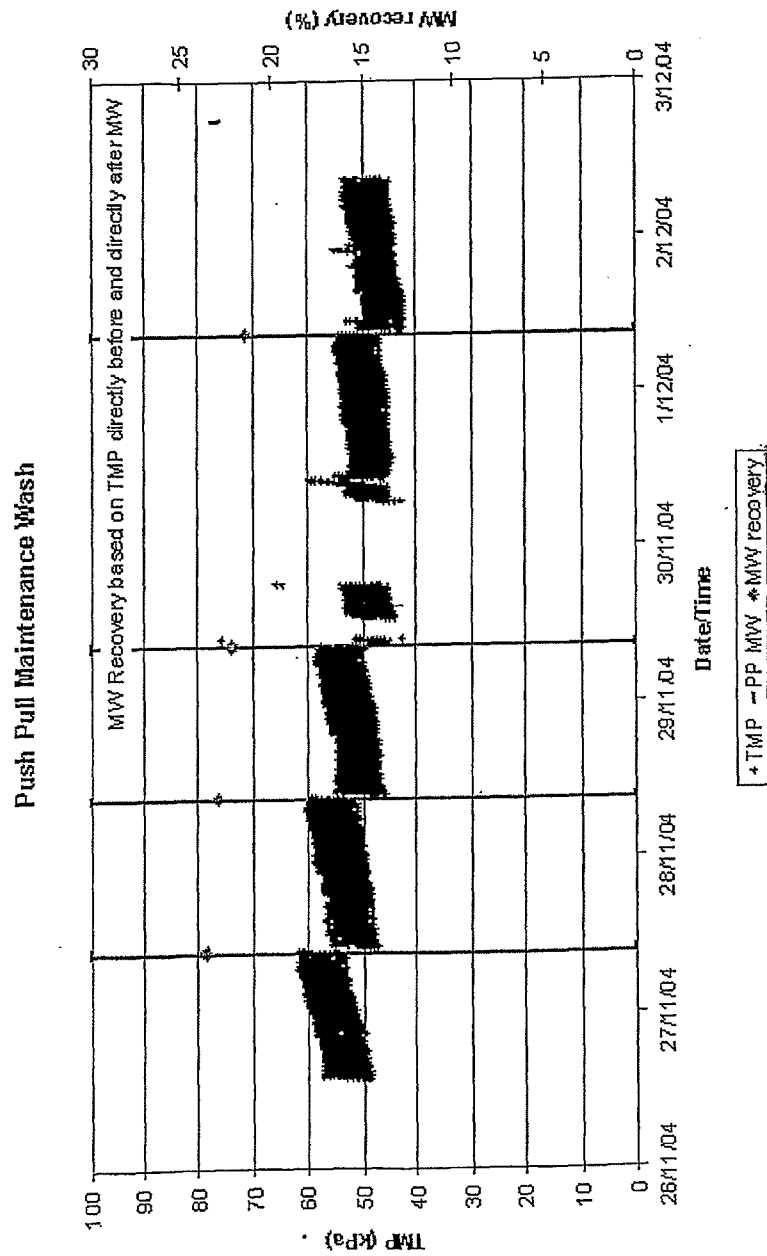


Fig. 10

Resistance over duration of CIP

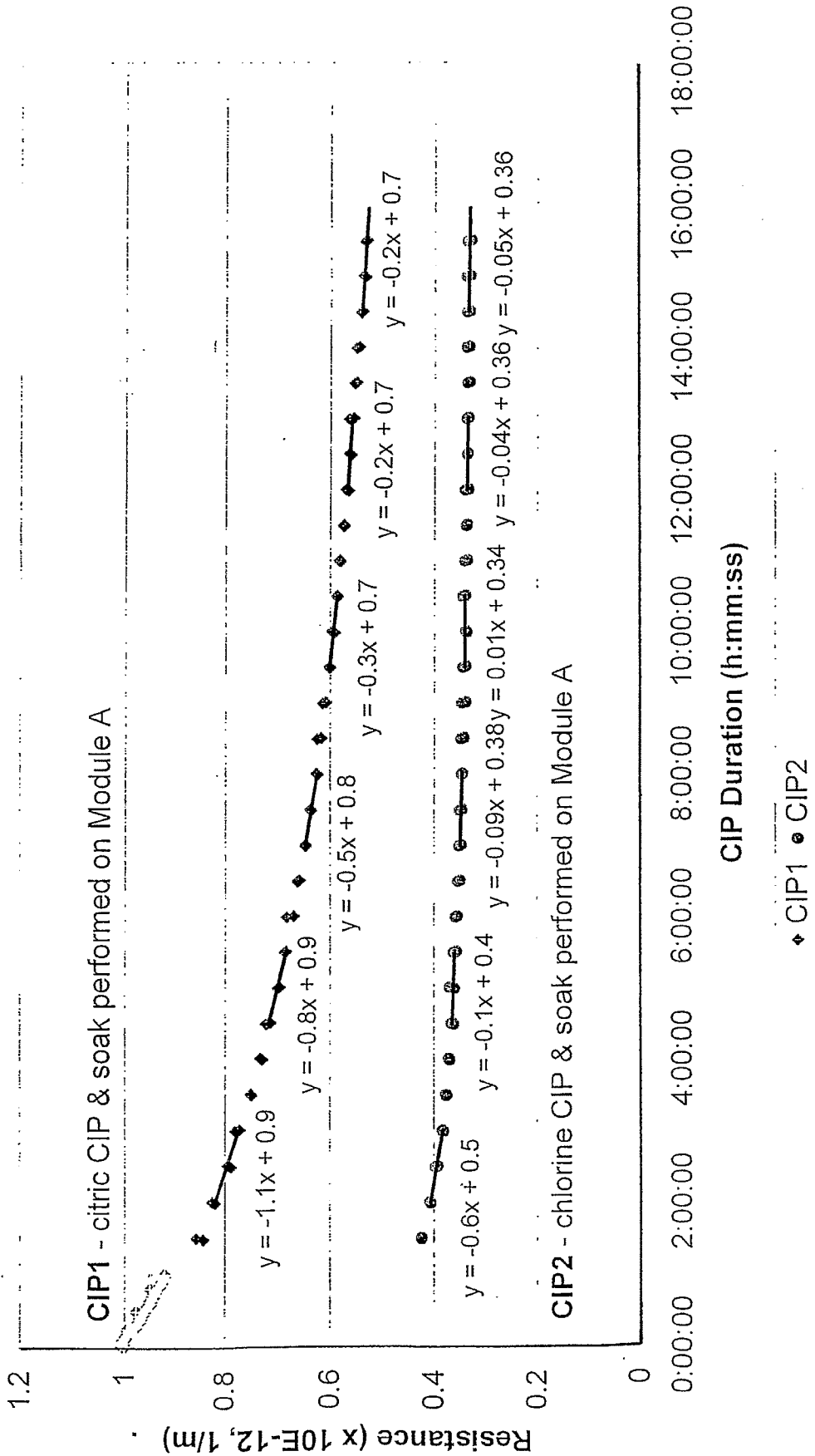


Fig 11

Fig. 12

Stepwise addition of chemical during resistance-measured CIP

